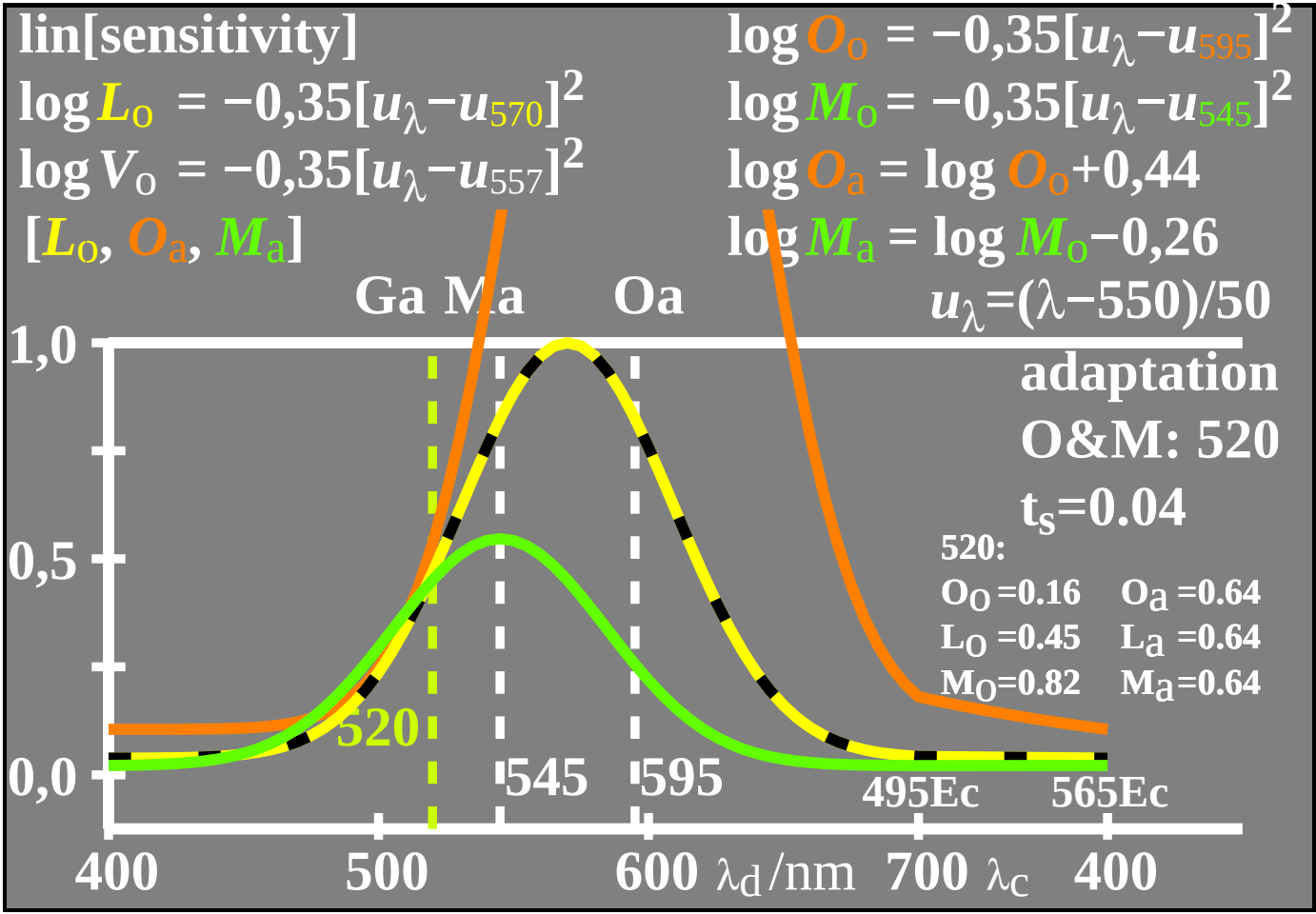
lin[sensitivity]
log L_o = −0,35[u_λ−u_{570}]^2
log V_o = −0,35[u_λ−u_{557}]^2
[L_o, O_a, M_a]
log O_o = −0,35[u_λ−u_{595}]^2
log M_o = −0,35[u_λ−u_{545}]^2
log O_a = log O_o+0,44
log M_a = log M_o−0,26
u_λ=(λ−550)/50
Ga Ma Oa
adaptation
O&M: 520
t_s=0.04
520:
O_o =0.16 O_a =0.64
L_o =0.45 L_a =0.64
M_o=0.82 M_a=0.64
1,0
0,5
0,0
520
545
595
495Ec
565Ec
400
500
600 λ_d/nm
700 λ_c
400

eex71−7a